## PROCEEDINGS OF SPIE

# Holography, Diffractive Optics, and Applications VIII

Yunlong Sheng Chongxiu Yu Changhe Zhou Editors

11–13 October 2018 Beijing, China

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Published by SPIE

**Volume 10818** 

Proceedings of SPIE 0277-786X, V. 10818

SPIE is an international society advancing an interdisciplinary approach to the science and application of light.

Holography, Diffractive Optics, and Applications VIII, edited by Yunlong Sheng, Chongxiu Yu, Changhe Zhou, Proc. of SPIE Vol. 10818, 1081801 ⋅ © 2018 SPIE CCC code: 0277-786X/18/\$18 ⋅ doi: 10.1117/12.2521843

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Please use the following format to cite material from these proceedings:

Author(s), "Title of Paper," in *Holography, Diffractive Optics, and Applications VIII*, edited by Yunlong Sheng, Chongxiu Yu, Changhe Zhou, Proceedings of SPIE Vol. 10818 (SPIE, Bellingham, WA, 2018) Seven-digit Article CID Number.

ISSN: 0277-786X

ISSN: 1996-756X (electronic)

ISBN: 9781510622340

ISBN: 9781510622357 (electronic)

Published by

SPIE

P.O. Box 10, Bellingham, Washington 98227-0010 USA Telephone +1 360 676 3290 (Pacific Time) · Fax +1 360 647 1445

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Printed in the United States of America.

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## **Contents**

vii	Authors
ix	Symposium Committees
xiii	Conference Committee
SESSION 1	DIGITAL HOLOGRAPHY
10818 02	Discovery of temporal universe (Invited Paper) [10818-1]
10818 03	Fast calculation of CGH using improved symmetric compressed LUT algorithm (Invited Paper) [10818-2]
10818 04	Image based wavefront sensorless adaptive optics in Fresnel incoherent correlation digital holography [10818-3]
SESSION 2	METAMATERIAL HOLOGRAMS
10818 0A	Single-particle detection using high-refractive index film coated in microring resonator [10818-9]
10818 OB	Broadband and high-efficiency half-waveplate based on dielectric metasurfaces [10818-10]
SESSION 3	COMPUTATIONAL IMAGING
10818 0E	Three-dimensional human face identification card [10818-14]
SESSION 4	DIFFRACTIVE GRATINGS I
10818 0G	Gratings theory for pico-optics applications (Invited Paper) [10818-18]
10818 OH	Three-dimensional measurement module of transverse odd-even combinational Dammann grating [10818-19]
10818 OJ	Method for measuring the spatial characteristics of high-resolution diffraction gratings [10818-21]

SESSION 5	3D DISPLAY AND METROLOGY
10818 OK	A directional backlight covered with pixelated nano-grating arrays [10818-22]
10818 OL	Dynamic 3D projection display system using printed holographic display plate [10818-23]
10818 OM	An experimental study on the contribution of different colors to binocular matching in 3D displays [10818-24]
10818 ON	Three-dimensional measurement method of structured light based on three measuring triangles [10818-25]
10818 00	High-precision 3D measurement of large-sized rough glass using phase-shifting and phase-height mapping [10818-26]
10818 OP	Transparent computer generated Fourier holograms for optical display and sighting system [10818-27]
SESSION 6	WAVEFRONT ENGINEERING I
10818 OR	Holographic sound propagation imaging (Invited Paper) [10818-88]
10818 OS	Communication with quantum limited subspace (Invited Paper) [10818-31]
10818 OT	Anisotropic geometric optical transformation based cylindrical vector beams multiplexing communication [10818-32]
10818 OU	Measuring the orbital angular momentum of light by dynamic polygon apertures [10818-34]
10818 OV	Orthogonal crossed gratings fabricated by scanning Dammann lithography [10818-35]
SESSION 7	WAVEFRONT ENGINEERING II
10818 0X	Comparative study of holographic, interferometric, and other tools for vortex beam analysis (Invited Paper) [10818-33]
10818 OZ	Phase-only LCOS modulator as a correcting element in digital holographic interferometers [10818-40]
SESSION 8	DIFFRACTIVE GRATINGS II
10818 10	Fabrication and measurement of gold reflective grating [10818-41]
10818 11	Wide-band two-port polarization-independent beam splitter based on an encapsulated transmission grating [10818-42]

10818 12	Four-port beam splitter of a single-groove grating [10818-43]
10818 13	Measurement of micro-angle based on the Talbot effect of 2D grating [10818-44]
10818 14	Optimization of test gratings and their measurement at manufacturing of diffractive optics and conformal correctors [10818-49]
SESSION 9	DIFFRACTIVE GRATINGS III
10818 15	Direct laser writing lithography technology based on rotating two-dimensional Dammann grating [10818-45]
10818 16	Quantum analysis on the Talbot effect of two-dimensional grating [10818-46]
10818 17	Sagnac polarized imaging resolved with two high-density gratings [10818-47]
	POSTER SESSION
10818 19	Mass production of computer-generated Fourier holograms and its application to prevent counterfeiting [10818-29]
10818 1A	Development of the methods of holographic optics for wavefront control in photonic systems [10818-39]
10818 1B	Investigation of structured head diffraction gratings for linear optical encoder [10818-50]
10818 1C	Automated optoelectronic system for diagnostics of optical variable devices [10818-51]
10818 1D	Generation of speckle vortices by double Archimedes' spiral micro-holes array [10818-52]
10818 1G	Holographic model on the mechanism of memory encoding, storage, and retrieval in the brain [10818-55]
10818 11	Evolution of phase singularities for a laser beam propagating through an inhomogeneous turbulent atmosphere [10818-57]
10818 1J	Optical element surface defect measurement with lensless digital holographic microscopy [10818-58]
10818 1K	Single assignment based nearest neighbor interpolation algorithm for digital holographic diffraction tomography [10818-59]
10818 1L	Design of polarization-insensitive transmission gratings for optical communication [10818-60]
10818 1N	Fast calculation of computer generated hologram using multi-core CPUs and GPU system [10818-62]

10818 10	Grating interferometry with high optical subdivision [10818-63]
10818 1P	Dielectric cavity enhanced high reflective multiband waveplate [10818-64]
10818 1Q	Precision focus plane searching in digital holography using axial adjacent amplitude similarity [10818-65]
10818 1R	Talbot effect in the focal field of a lens [10818-66]
10818 15	New high-performance opto-electronic scanner for authentication [10818-67]
10818 1U	Optimized design of double-plate full-color holographic waveguide display [10818-69]
10818 1V	Optimal unequal phase steps for laser direct writing in DPE manufacturing [10818-70]
10818 1W	Analysis of holographic lightguide's optical parameters for AR devices [10818-71]
10818 1X	Design and fabrication of a variable-line-space grating surface for a Fresnel-grating lens based miniature spectrometer [10818-72]
10818 1Y	Research of two-wavelength filter based on guided-mode resonance of two-dimensional gradient-period grating [10818-73]
10818 1Z	The forming mechanism of microstructure of crossed holographic photoresist grating [10818-74]
10818 20	Coherent optical phase recovery method based on boundary condition [10818-75]
10818 21	Resolution characteristics in scanning digital holography with sub-pixel shifting reconstruction imaging [10818-76]
10818 22	<b>Voxel-based algorithm for calculating 3D computer generated hologram with occlusion effect</b> [10818-77]
10818 23	A combination of computer generated Fresnel holograms and light guide substrate with diffractive optical elements for optical display and sighting system [10818-78]
10818 26	Implementation of off-axis digital holography using a single diffraction grating [10818-81]
10818 28	A random dot stereoacuity test for different colors in 3D displays [10818-83]
10818 29	High-precision 3D shape measurement based on time-resolved VCSEL [10818-84]
10818 2A	Fabrication of double-periodic graded photonic crystal array [10818-85]
10818 2B	Improvement on the different scene depth of effective perspective images' segmentation and

#### **Authors**

Numbers in the index correspond to the last two digits of the seven-digit citation identifier (CID) article numbering system used in Proceedings of SPIE. The first five digits reflect the volume number. Base 36 numbering is employed for the last two digits and indicates the order of articles within the volume. Numbers start with 00, 01, 02, 03, 04, 05, 06, 07, 08, 09, 0A, 0B...0Z, followed by 10-1Z, 20-2Z, etc.

Akimenko, Andrey, 19 Anikeeva, A. A., 1W Balbekin, Nikolay, 0Z Banguilan, Dina Grace, 0U Bareza, Nestor, Jr., 0U Belousov, Dmitrij A., 14 Betin, Alexander Yu., 0P Bu, Fantao, 0O, 0V, 10 Calin, Bogdan Stefanita, 1V Cheburkanov, Vsevolod, 1C, 1S

Cheburkanov, vsevolo
Chen, Xinrong, 1Y, 1Z
Chen, Kai, 0M, 28
Chen, Linsen, 0K
Chen, Xu, 1Z
Chen, Yan, 1J
Chen, Yibei, 2B
Chen, Zaiqing, 0M, 28
Cheng, Feiyan, 0M
Cheng, Yushui, 1Y
Chi, Weining, 1K
Cui, Xun, 20
Cui, Yutong, 21
Dai, Qi, 0B

Deng, Juan, 0B
Deng, Liangui, 0B
Drozdova, Catherine A., 0P
Escoto, Esmerando, 0U
Fang, Juncheng, 0T
Fu, Shenggui, 11
Gao, Shuai, 0L
Gao, Yang, 1U
Gavril'eva, K. N., 0X
Ge, Xiaolu, 11
Geng, Menglin, 1X
Grad, Va. A. 1A. 1W

Grad, Ya. A., 1A, 1W Gu, Ke, 04 Gui, Feng-Ji, 0A Gui, Jinbin, 1N Guo, Liping, 11 Guo, Yanling, 1Z Han, Fenglin, 21 Han, Kezhen, 11 He, Aga, 1Q

Hermosa, Nathaniel, 0U

Hu, Jingpei, 1P Hui, Lin, 1X Hua, Erkai, 0K Huana, Gaokun,

Huang, Gaokun, 13, 16 Huang, Huijie, 1P Huang, Xiaoqiao, 28 Jia, Wei, 0G, 0H, 0V, 12, 15, 17

Jia, Yanyan, 21
Jiang, Zhixiang, 1N
Jiang, Zhuqing, 21
Jin, Hailan, OL
Jin, Xiaoyu, 1N
Jing, Wenbo, 20
Kang, Guoguo, OL
Kang, Ming-Wu, 1U
Kolyuchkin, Vasily, 1C, 1S
Korolkov, Victor P., 14

Kovalev, Michael S., OP, 19, 1A, 1B, 23

Krasin, G. K., 1A Lee, Byoungho, 26 Lee, Byounghyo, 26 Lei, Ting, 0T Li, Chao, 0E, 0N, 0O, 29 Li, Chaoming, 1Y, 1Z Li, Minkang, 0G, 0V, 10, 10

Li, Mu-Neng, 0A
Li, Rui-Hua, 1U
Li, Xinghui, 1X
Li, Zile, 0B
Liu, Chuan, 1G
Liu, Juan, 03
Liu, Shou, 1G
Liu, Tingting, 1D
Liu, Yixin, 1X
Liu, Zhao, 0N
Liu, Zichen, 0B
Lou, Yuli, 1N
Lu, Haiou, 1X
Lu, Qinghong, 1G
Lu, Yunkai, 0V, 10, 11

Luculescu, Catalin Romeo, 1V

Lushnikov, D. S., 1B Man, Tianlong, 04 Man, Zhongsheng, 11 Markin, V. V., 1B Matoba, Osamu, 0R Mermoul, A., 0X Miao, Chaofeng, 29 Mihailescu, Mona, 1V Mihale, Nicolae, 1V Naiden, Liudmila, 1S Nasyrov, Ruslan K., 14

Ni, Kai, 1X Nikolaev, V. V., 1W

Odinokov, Sergey B., OJ, OP, 19, 1A, 1B, 1C, 1S, 1W, 23 Paun, Irina Alexandra, 1V Peng, Weiting, 03 Petrov, Nikolai, OZ Piryutin, Nikolay, 1S Popov, V. V., 0J Pul'kin, Sergei, 0Z Qi, YongLe, 2A Qiao, Wen, 0K Qin, Rikang, 21 Rajput, Sudheesh K., OR Rong, Lu, 1K Ruchka, Pavel, 19 Scarlat, Eugen I., 1V Sevryugin, Alexander, 0X, 0Z Shang, Si-Hui, 0A Shi, Jiacheng, OK Shi, Junsheng, 0M, 28 Shi, Lingyan, 22 Shishova, M. V., OJ, 1B, 1W Shoev, Vladislav, OZ Shubenkova, E. V., 0X Smirnov, Andrey, 19 Solomashenko, A. B., 1W Song, Shujie, 04 Stsepuro, Nikita G., 0P, 19, 1B, 23 Su. Jian, 2B Su, Yanfeng, 22 Sun, Haibin, 1D Sun, Ping, 1D Sun, Xiaodong, 1P Sun, XiaoHong, 2A Tai, Yonghang, 0M Talalaev, Vladimir, 1C, 1S Tan, Xiaodi, OL Tang, Yu, 1Y Tao, Jin, OB Touil, M., 0X Tranca, Denis, 1V Tsyganov, Ivan, 1C, 1S Tursunov, Ibragim M., 0X, 0Z Venediktov, Dmitriy V., 0Z Venediktov, Vladimir, 0X, 0Z Wan, Yuhong, 04 Wang, Dayong, 1K Wang, Guoqing, 1N Wang, Jin, 0H, 12, 15, 17 Wang, Rui, 1Y, 1Z Wang, Shuai, 2A Wang, Weiqi, 1X Wang, Yongtian, 03 Wang, Yunxin, 1K Wei, Chunlong, 0G, 0V, 1O Wu, Jianhong, 1L, 1Y, 22 Wu, Lin, OB Wu, Xiumei, 0K Xiang, Changcheng, 0G, 0H, 12, 15, 17

Xiang, Xiansong, 0G, 0V Xiao, Xue, OL Xie, Yi, 1U Xie, Yongfang, 15, 17 Xie, Zhenwei, OT Xu, Haiyan, 1Y, 1Z Xu, Xing, 13, 16 Xue, Zhenfa, 1R Yan, Lulu, 1J Yan, Xingpeng, 2B Yan, Yu, 0E, 0O Yanev, A.S., 1W Yang, Rui, 1R Ye, Jing, 29 Yu, Francis T. S., 02, 0S Yu, Junjie, 0E, 11, 10 Yu, Xiaojin, 1J Yu, Yingjie, 10 Yuan, Xiaocong, 0T Yuan, Yuanyuan, 1K Yun, Lijun, 0M, 28 Zeng, Aijun, 1P Zhang, Chong, 1P Zhang, Teng, 2B Zhang, Xiangsu, 1G Zhang, Yuanying, 1G Zhang, Yunli, OK Zhang, Zhi-Hong, 0A Zhao, Dong, 0H, 15 Zhao, Jie, 1K Zhao, Tao, 03 Zhao, Zhiyuan, 20 Zheng, Guoxing, 0B Zherdev, A. Y., OJ, 1B Zhou, Changhe, 0E, 0G, 0H, 0N, 0O, 0V, 10, 11, 12, 15, 17, 10, 29 Zhou, Feng, 0K, 1L, 22 Zhou, Ligiang, 1R Zhou, Qian, 1X Zhou, Sumei, 13, 16 Zhu, Linglin, 1P Zhu, Linwei, 1R Zhu, Shiyao, OV, 10 Zlokazov, Evgenii Yu., 1S, 23 Zou, Huanhuan, 20 Zou, Wenlong, 1L

Xiang, Guang-Xin, 1U

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